



Attorney Docket No. 108298714US
Disclosure No. 03-0116.00/US

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Zheng et al.

Application No.: 10/767,298

Confirmation No.: 5002

Filed: January 28, 2004

Art Unit: 2824

For: METHODS FOR FORMING SMALL-
SCALE CAPACITOR STRUCTURES

Examiner: M. K. Luhrs

INFORMATION DISCLOSURE STATEMENT (IDS)

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A copy of each Non-U.S. Patent and each Non-Patent Literature article listed on the PTO/SB/08 is attached. A copy of the U.S. Patents listed on the PTO/SB/08 has not been provided. A full translation of the non-English language references marked by a check mark (✓) is enclosed. An abstract is enclosed for all other non-English language references. Applicant has not verified that the translation or abstract is an accurate

representation of the teachings of the non-English reference, though, and reserves the right to demonstrate otherwise.

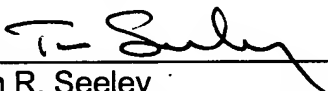
In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

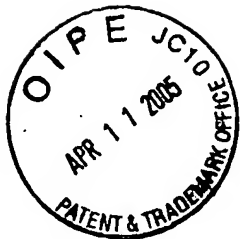
It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0665, under Order No. 108298714US.

Dated: April 7, 2005

Respectfully submitted,

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Complete if Known	
				Application Number	10/767,298-Conf.# 5002
				Filing Date	January 28, 2004
				First Named Inventor	Lingyi A. Zheng
				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	1	of	13	Attorney Docket Number	108298714US

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Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
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				Art Unit	2824
				Examiner Name	Michael K. Luhrs
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				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	3	of	13	Attorney Docket Number	108298714US

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				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	4	of	13	Attorney Docket Number	108298714US

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				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	5	of	13	Attorney Docket Number	108298714US

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				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	6	of	13	Attorney Docket Number	108298714US

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				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	7	of	13	Attorney Docket Number	108298714US

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				Examiner Name	Michael K. Luhrs
Sheet	8	of	13	Attorney Docket Number	108298714US

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				First Named Inventor	Lingyi A. Zheng
				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	9	of	13	Attorney Docket Number	108298714US

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				Art Unit	2824
				Examiner Name	Michael K. Luhrs
Sheet	10	of	13	Attorney Docket Number	108298714US

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Sheet	11	of	13	Attorney Docket Number	108298714US

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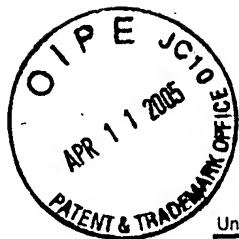
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	First Named Inventor	Lingyi A. Zheng	
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